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Application Number		10602468		
Filing Date		2003-06-23		
First Named Inventor	Venkat Selvamanickam			
Art Unit		1784		
Examiner Name	Aaron Austin			
Attorney Docket Number		1014-SP156-US		

Examiner Initial*	No No	Patent Number	Code <sup>1</sup>			of cited Docu	entee or Applicant iment	Relevant Passages or Relevan Figures Appear		ant
/AA/	1	6596085	B1	2003-07-22		Schmitt et al.		Corresponds to KR2001-78241.		
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/AA/	1	2001-78241	KR			2001-08-20	Applied Materials, Inc.		Corresponds to US 6596085,	
/AA/	2	2001-111027	KR			2001-12-15	Toshiba Ceramics Co.		Corresponds to US 20020009868.	
/AA/	3	11-329116	JP		۸	1999-11-30	Fujikama Ltd.			v

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xaminer Name	Aaron Austin				
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